



FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICATION	ATTY. DOCKET NO.: 11417-US-PA	APPLICATION NO.: 10/707,358
	APPLICANT: Wang	
	FILING DATE: Dec. 8, 2003	GROUP 2811

U.S. PATENT DOUCMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FIILNG DATE (IF APPROPRIATE)

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	FIILNG DATE (IF APPROPRIATE)

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)
C.L. <i>SPL</i>	Chuang, D. R., <i>VLSI Process Technology</i> , 1997/2/15, p.404, Figure 11-9.

EXAMINER <i>Shen</i>	DATE CONSIDERED <i>11/22/04</i>
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